

## N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hideki IWAKI

Application No. 09/994,683

Filed: November 28, 2001

MULTI-LEVEL CIRCUIT SUBSTRATE,

METHOD FOR MANUFACTURING

SAME AND METHOD FOR

ADJUSTING A CHARACTERISTIC

IMPEDANCE THEREFOR

TC/Art Unit: 2826

Examiner: Leonardo Andujar

Attorney Docket: P64916US1

FECHNOLOGY CENTER 2800

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents PO Box 1450 Alexandria, Virginia 22313-1450

Sir:

This is a PETITION FOR EXTENSION OF TIME for a two-month period pursuant to 37 C.F.R. §1.136(a). This PETITION FOR EXTENSION OF TIME is being concurrently filed with a RESPONSE AND AMENDMENT. A check in the amount of \$420.00 is enclosed with this Petition in accordance with 37 C.F.R. §1.17(a)(1)-(5). If this fee is inaccurate please debit or credit Deposit Account No. 06-1358.

11/21/2003 MDANTE1 00000028 09994683

01 FC:1252

420.00 DP

Respectfully submitted,

JACOBSON HOLMAN, PLLC

Date: 19 November 2003

Customer No. 000,136

400 Seventh Street, N.W.

Washington, D.C. 20004-2201

Attorney Docket:

P64916US1

By Nathanel G. Humphres 1 Nathaniel A. Humphries Registration No. 22,772